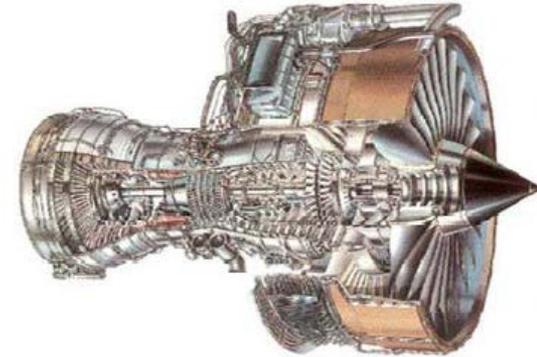
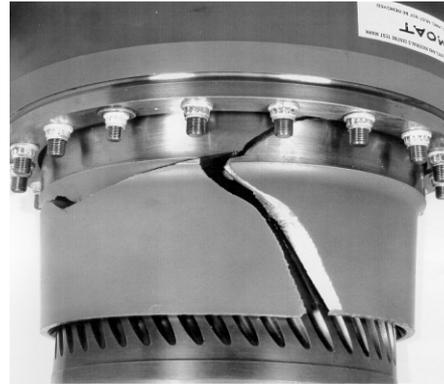
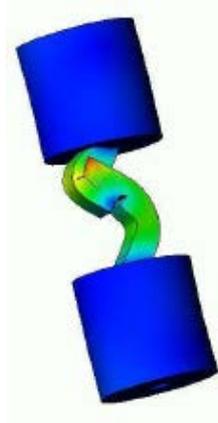


Exceptional service in the national interest

N=O=MAD
Research Institute



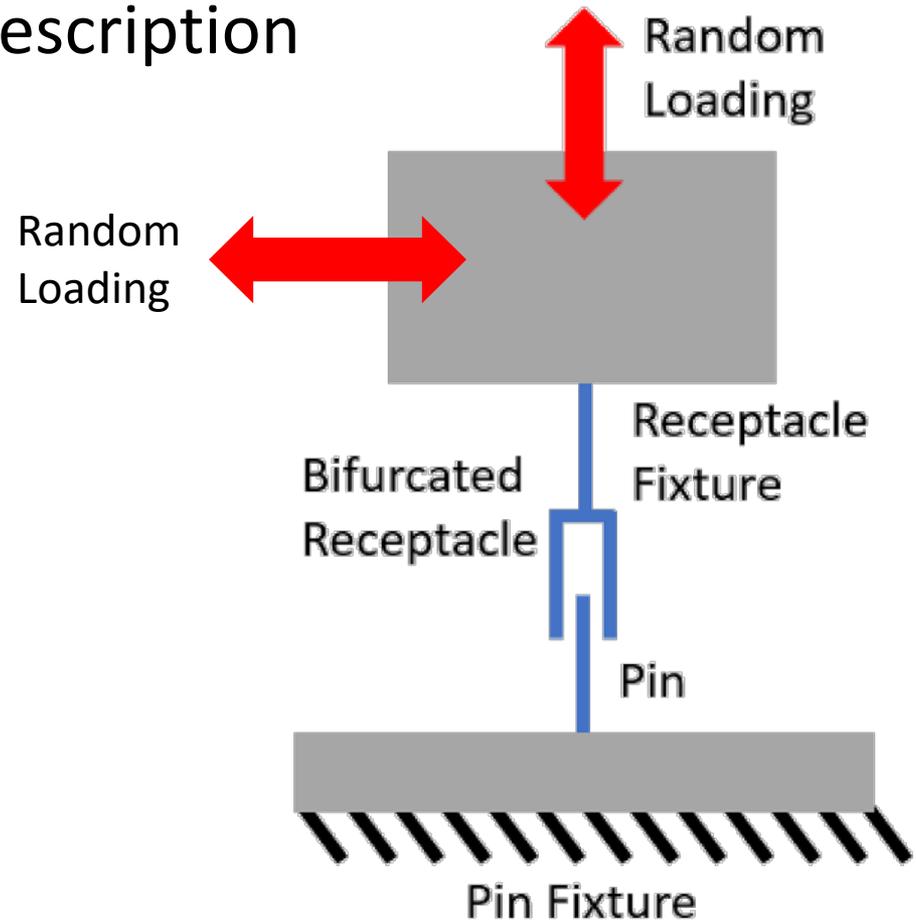
Investigation of Electrical Contact Chatter in Pin-Receptacle Contacts

Students: Brianna Johnson, Chris Schumann, and Fadi Rafeedi

Mentors: Rob Flicek, Kelsey Johnson, Karl Walczak,
Cory Medina, Dane Quinn, Benjamin Zastrow, Rob Kuether

Outline for Presentation

- Motivation & Project Description
- Modal Testing
- Chatter Testing
- Data Processing
- Closing Remarks

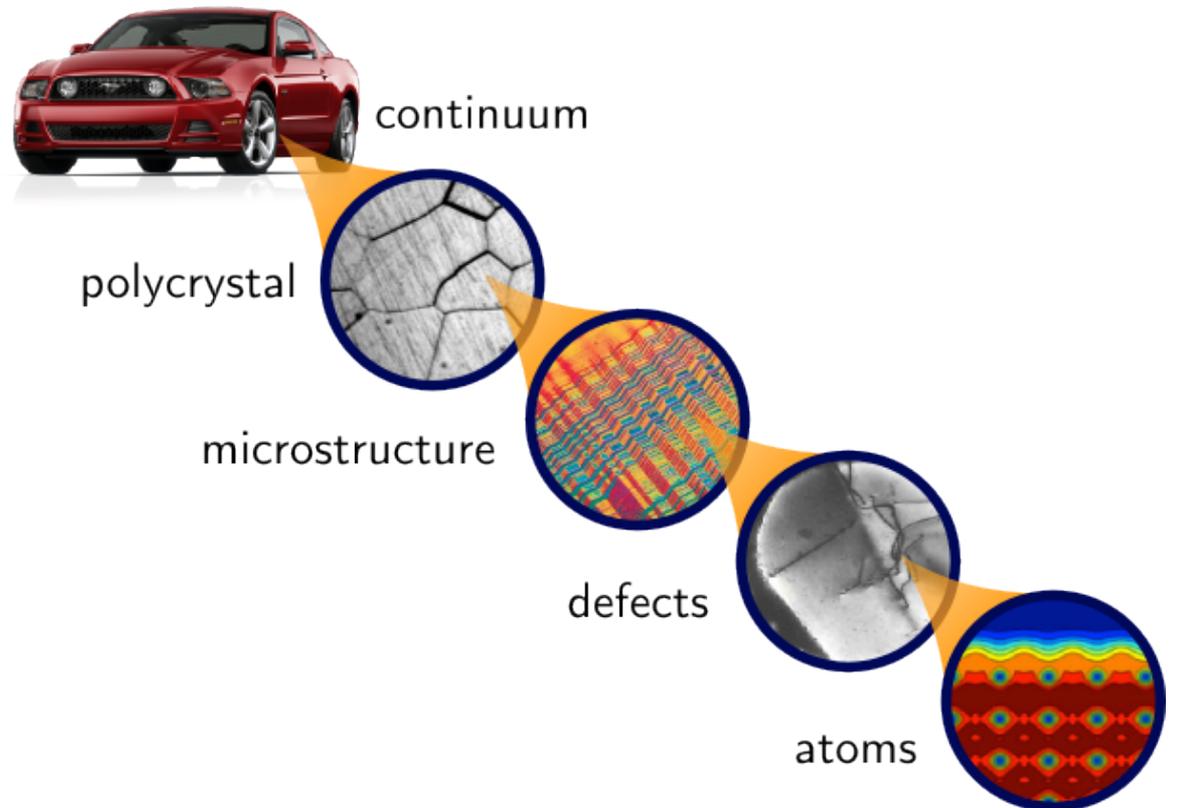


Motivation

- **Electrical contact chatter** refers to the sudden degradation of electrical current flow through a closed circuit
- Generally defined as the electrical resistance of the contact exceeding a threshold for a specified duration of time
 - 150 Ohms for 25 ns for our project
- Observed to occur when electrical contacts are subject to severe **random vibration environments**
- Previous experiments were system level, could not record inputs to pin and receptacle
- **What causes chatter?**
- **How can we predict chatter?**

Chatter is a Multiscale Physics Problem

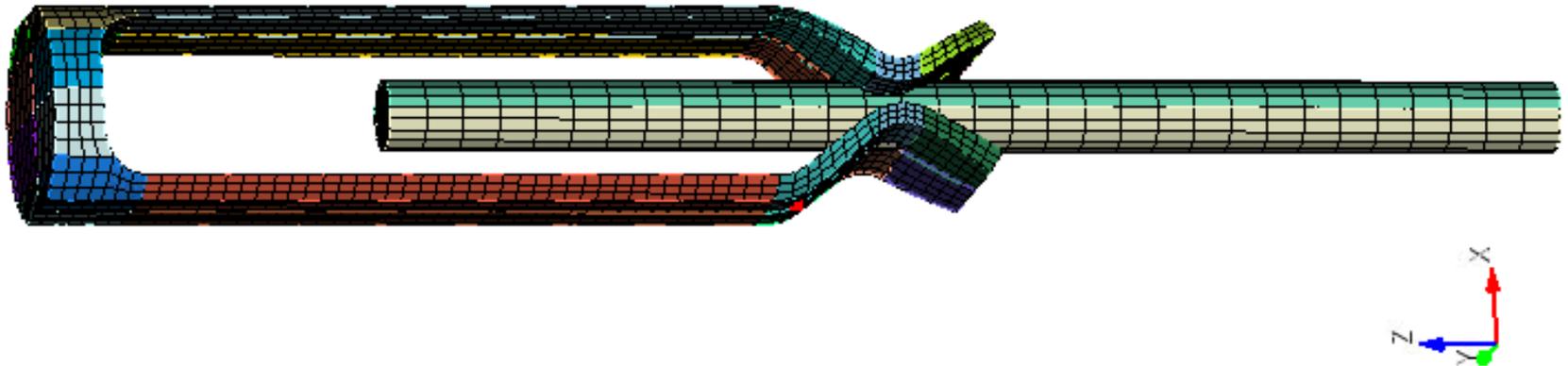
- Component (cm) to surface texture (nm)
- Short timescale (ns)
- Disciplines such as:
 - **Contact mechanics**
 - **Structural dynamics**
 - Tribology
 - Lubrication
 - Electrostatics
 - Etc.



<https://solids.uccs.edu/images/multiscale.png>

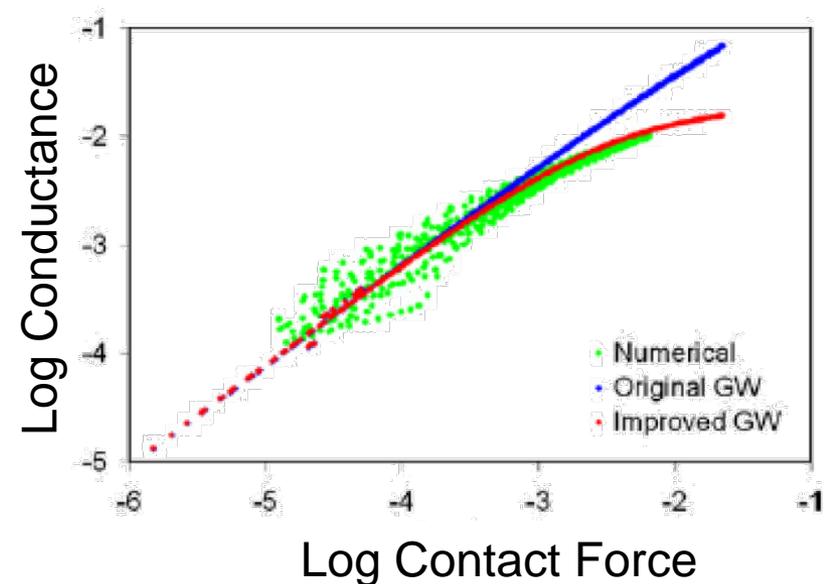
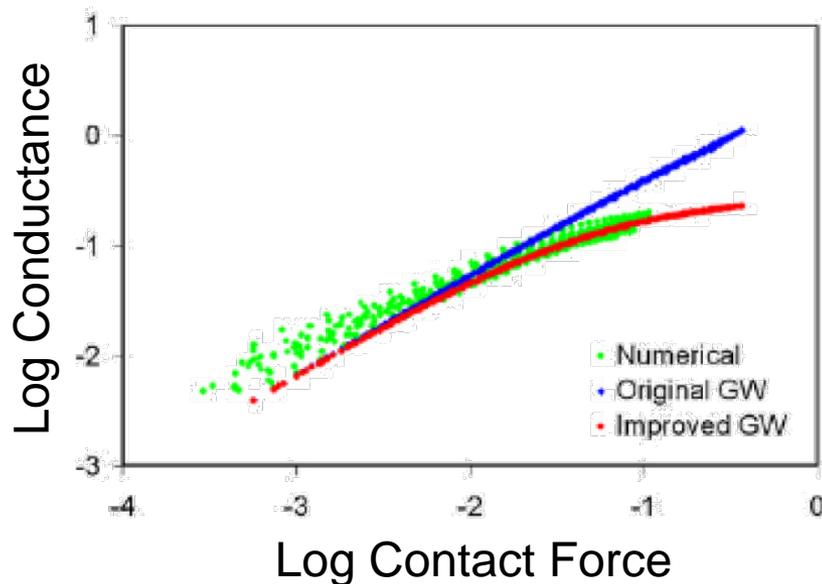
Computational Contradictions

- Detailed contact mechanics models are often **quasi-static**
- Chatter is a **high frequency dynamic** event
- Balance between critical timestep and a mesh fine enough to accurately capture contact



Contact Force to Contact Resistance

- Linear relationship between contact force and contact resistance (Ciavarella, et al., 2008)

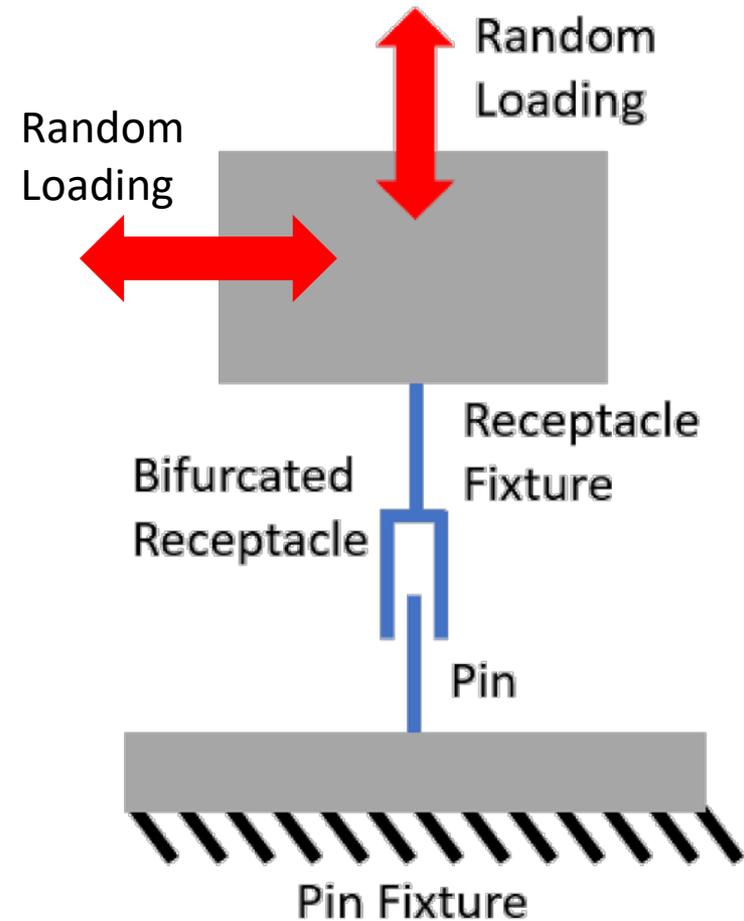


Ciavarella, et al., Inclusion of "interaction" in the Greenwood and Williamson contact theory 2008

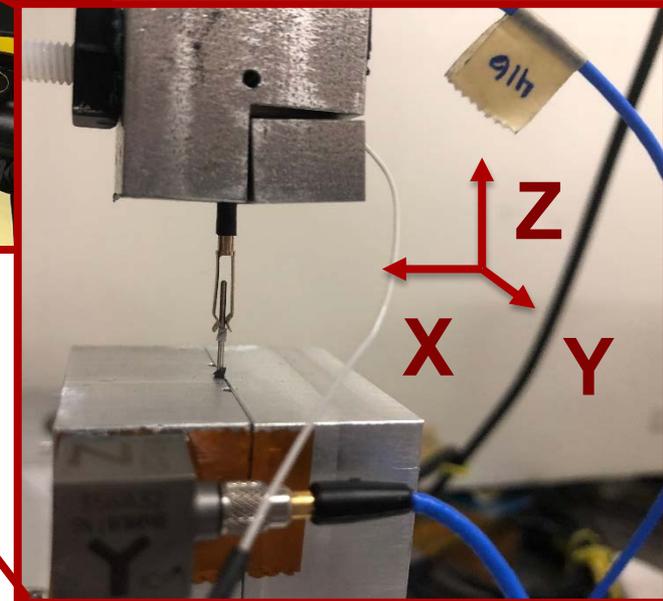
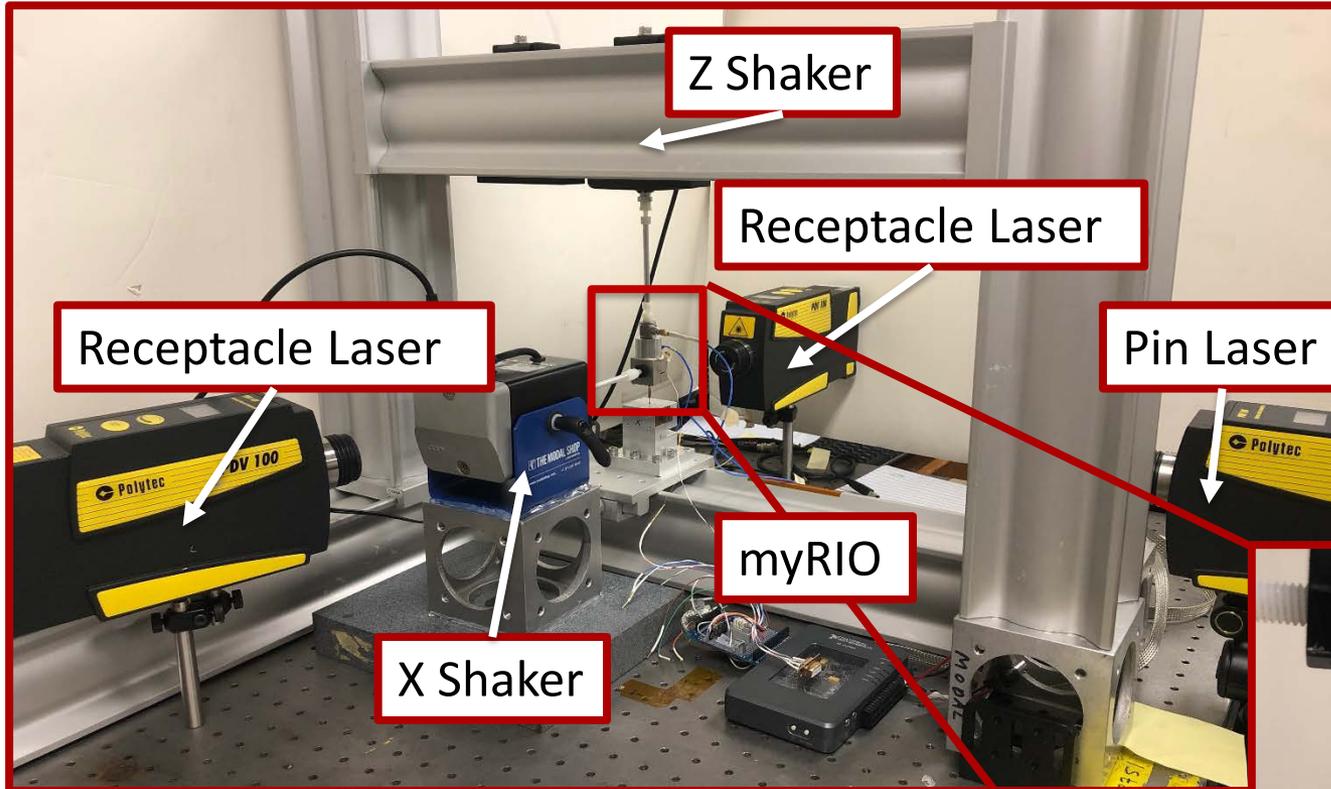
- Use contact force as a metric of chatter to correlate events between test and FEM

Project Objectives

- **Goal: To perform a fundamental investigation of the physics governing chatter using a single electrical circuit with contact between a pin and a bifurcated receptacle**
- **Tasks**
 - Modal tests of parts and assembly
 - Record chatter from random vibration environments
 - Create FEM to simulate test results
 - Study relationship between system inputs and chatter



Test Setup - Mechanical



Introduction

Motivation

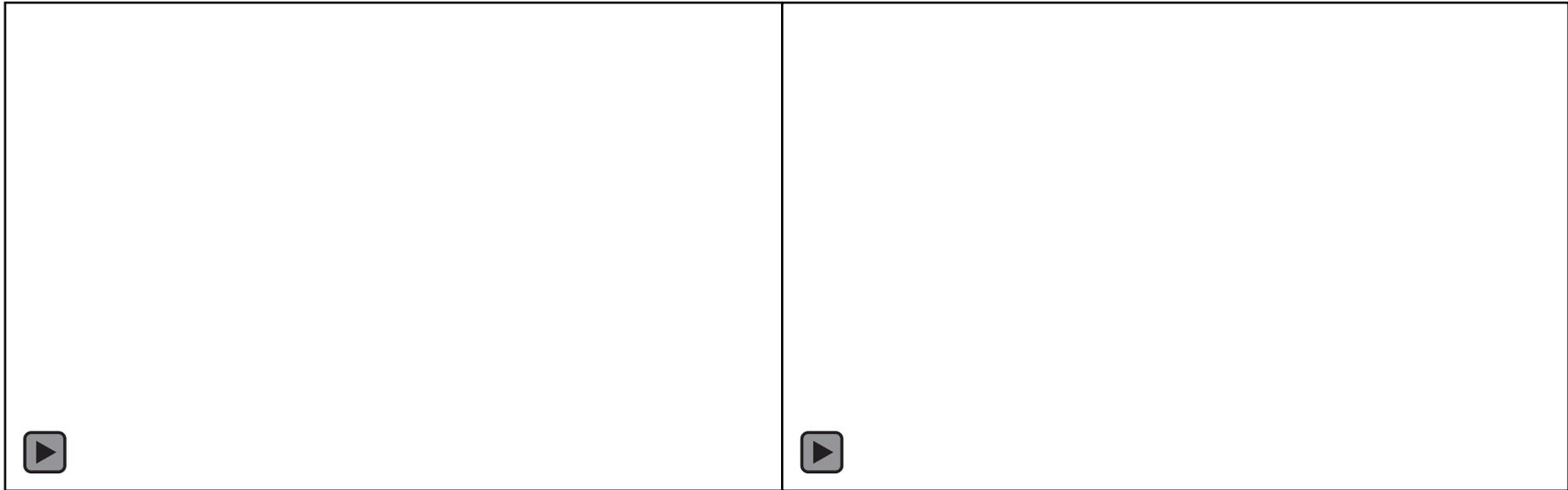
Modal

Chatter

Data

Conclusion

Modal Testing

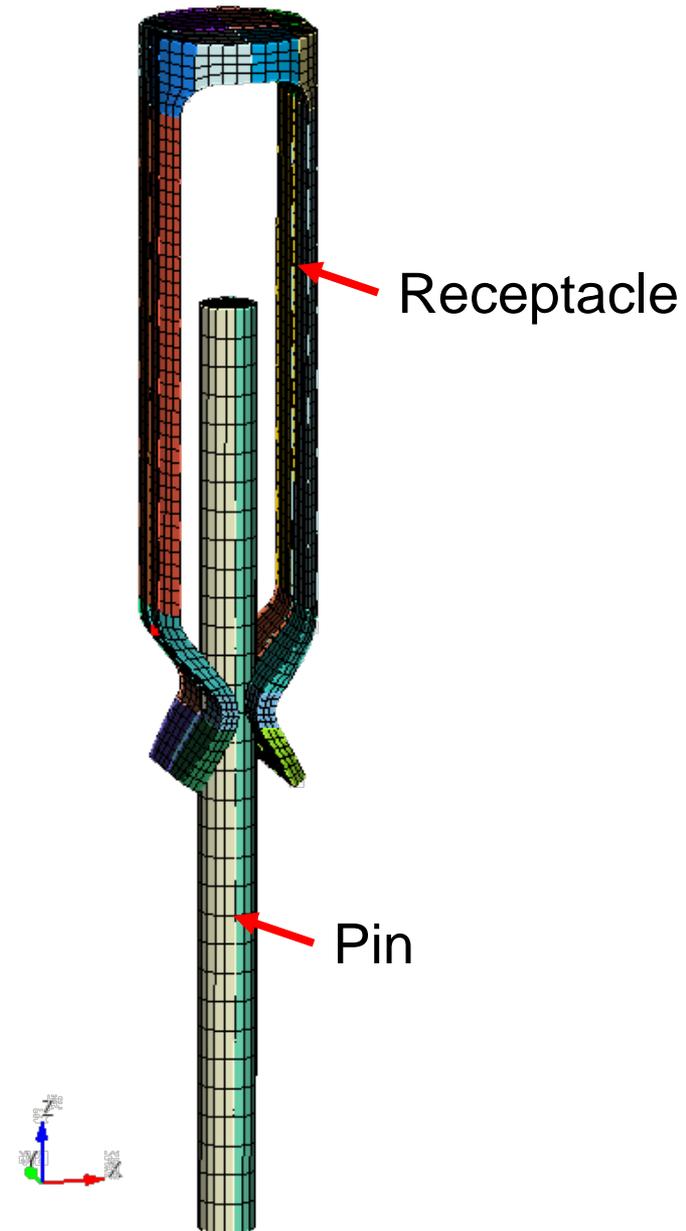


Mode 1: 758 Hz

Mode 2: 780 Hz

Finite Element Model

- Geometry
 - Pin: created in cubit, simple shape
 - Receptacle: uploaded from manufacturer file
- Mesh:
 - Low element count (5k) to reduce runtime
 - Coarse pin model to reduce artificial chatter



Receptacle Updating



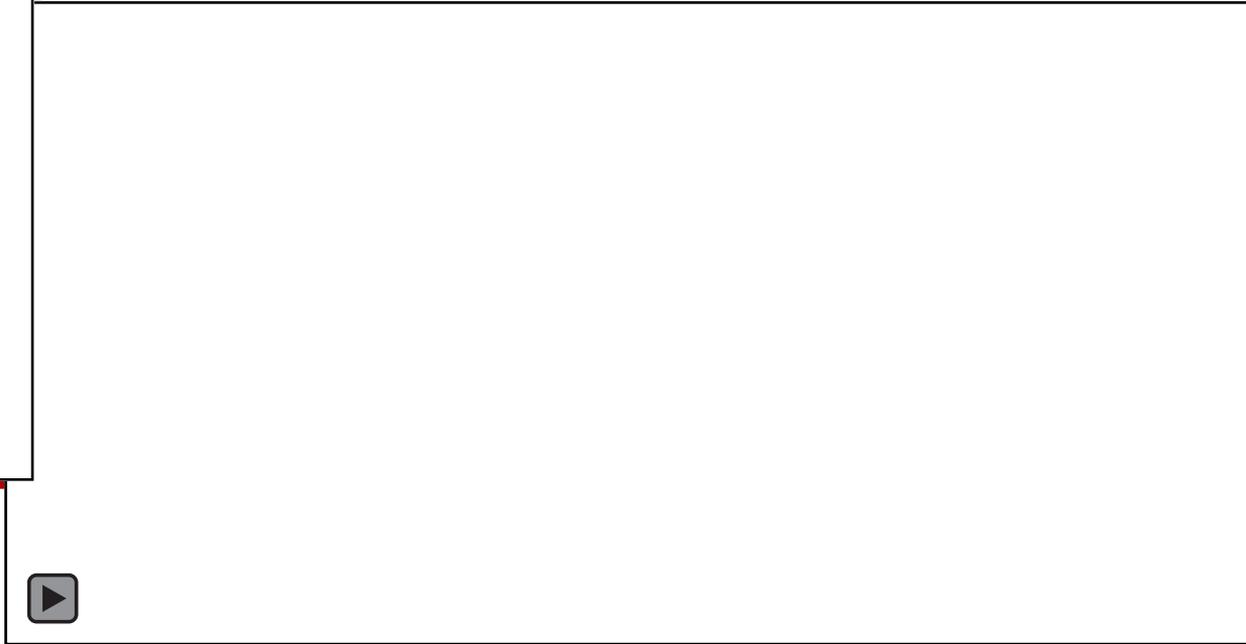
Receptacle Mode 1

Mode Description	Experimental Frequency [Hz]	Updated FEM Frequency [Hz]	% Error
In-phase 1 st bending mode	757.7	770.3	1.66%

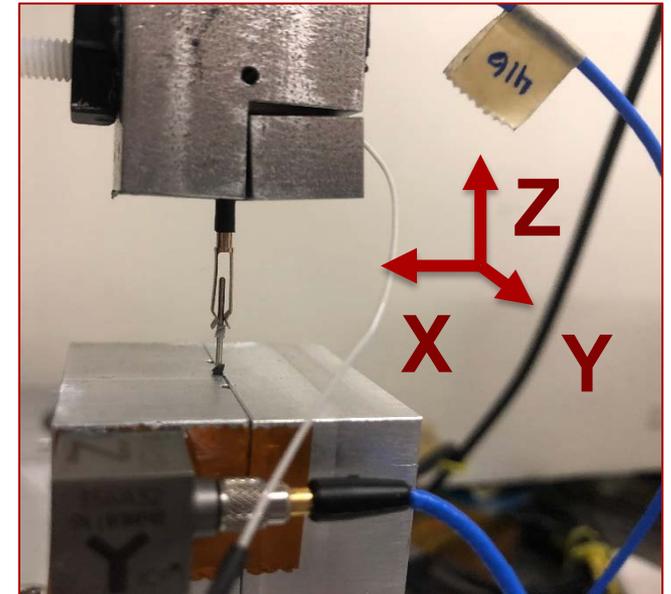
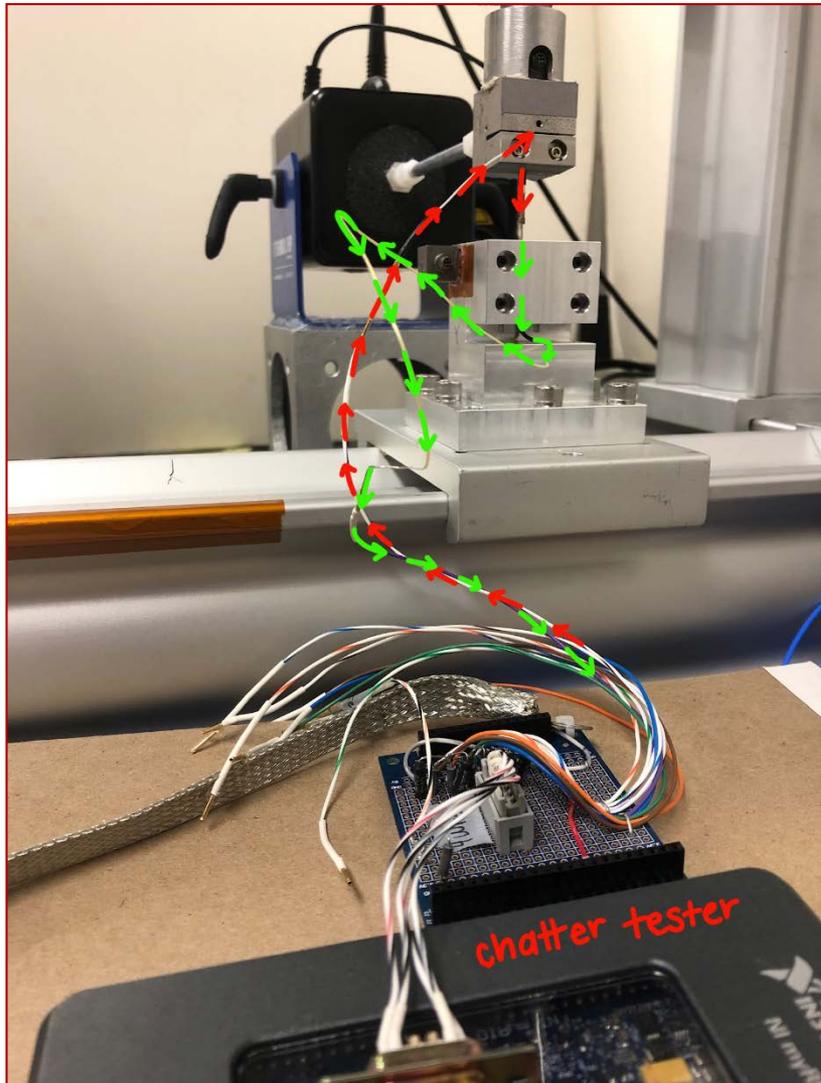


Receptacle Mode 2

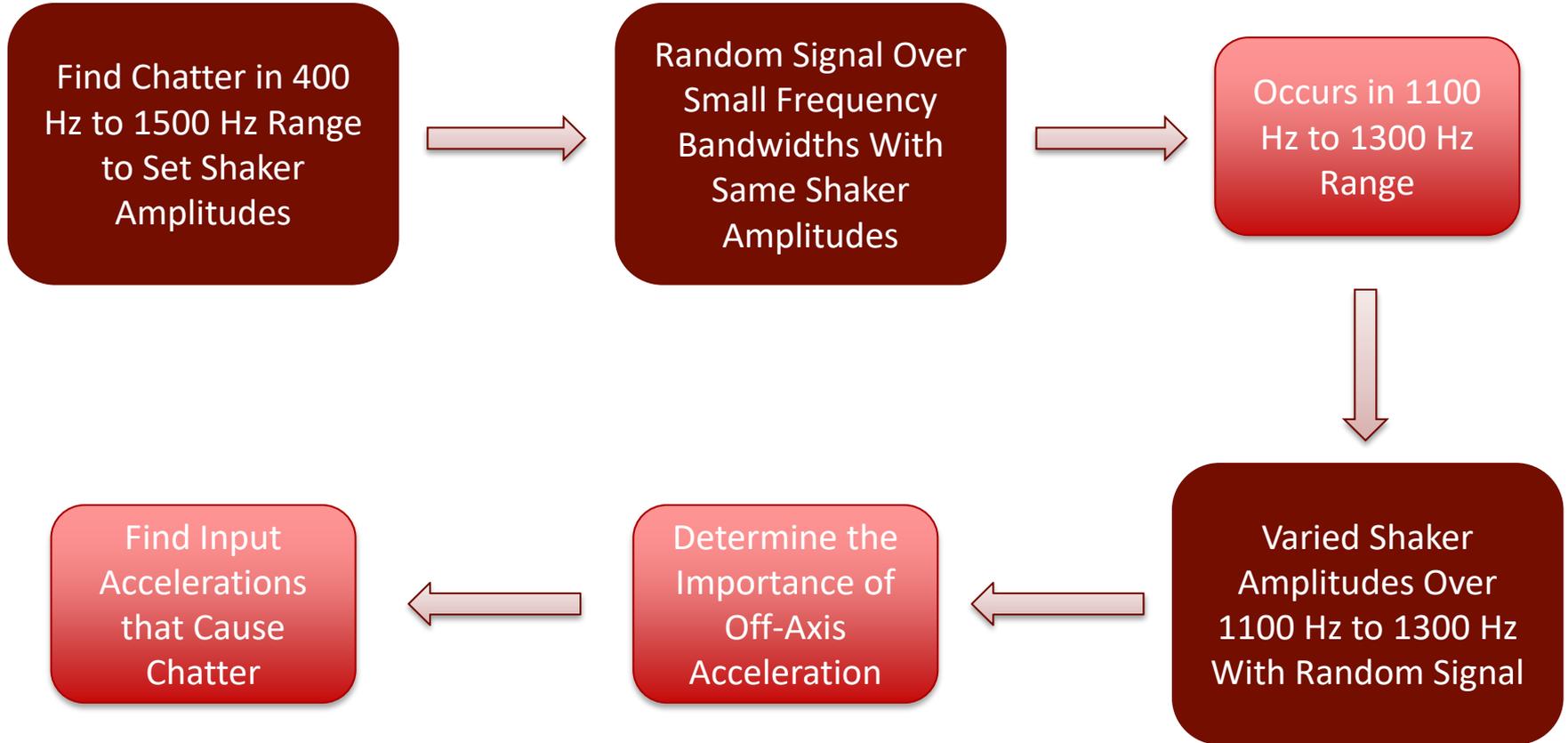
Mode Description	Experimental Frequency [Hz]	Updated FEM Frequency [Hz]	% Error
Out-of-phase 1 st bending mode	780.0	770.4	-1.24%



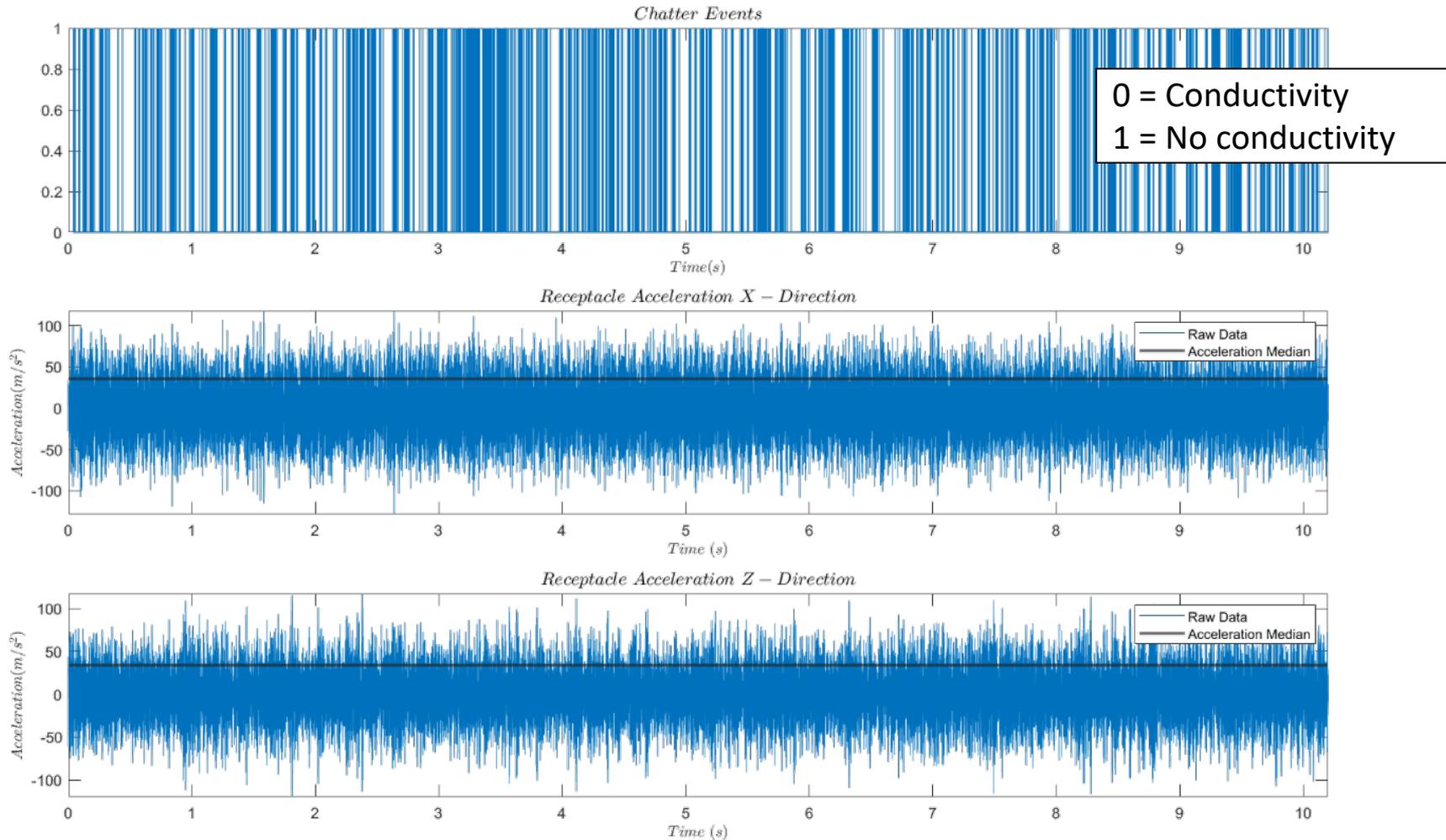
Test Setup - Electrical



Chatter Test Experimental Design



Raw Test Data



Analysis Across Multiple Runs

Introduction

Motivation

Modal

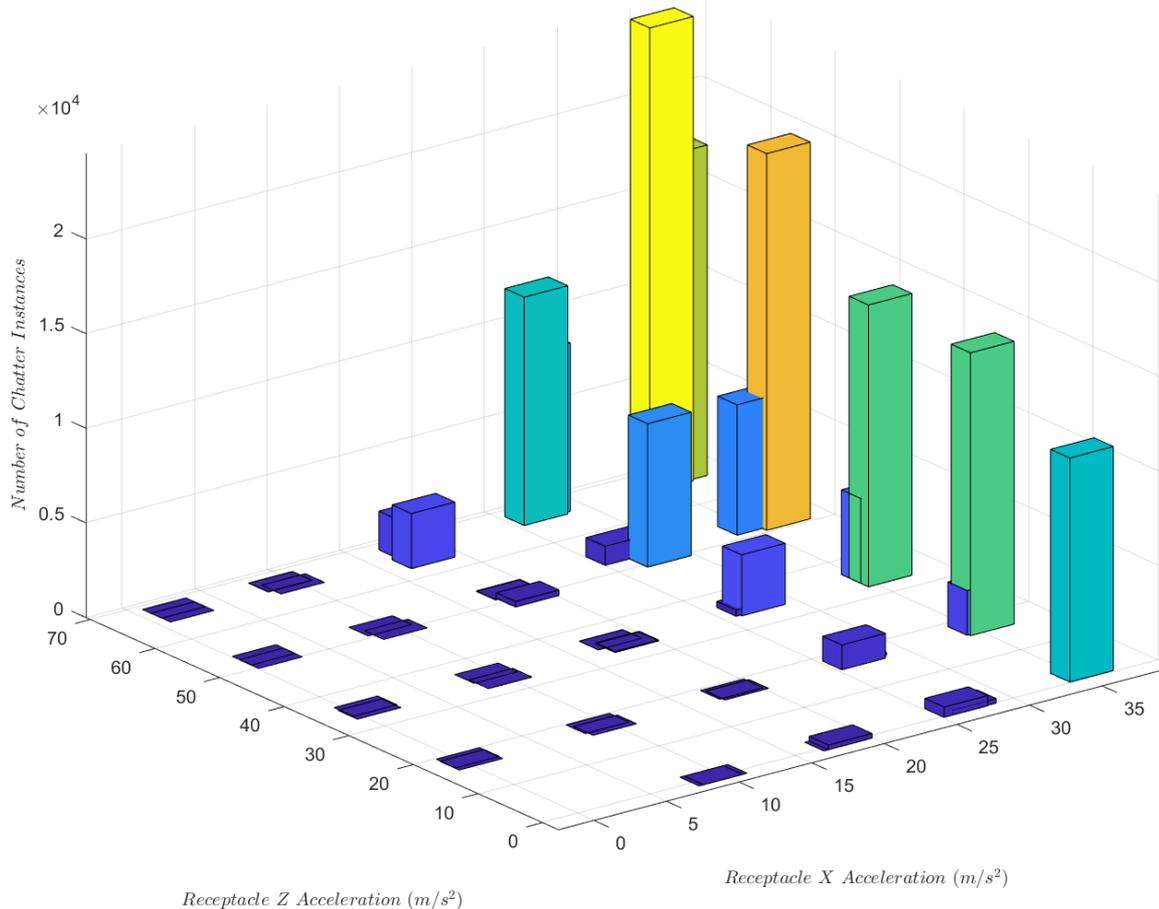
Chatter

Data

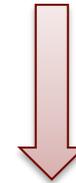
Conclusion

Combination of Accelerations for Chatter

Number of Chatter Instances Versus Receptacle Acceleration

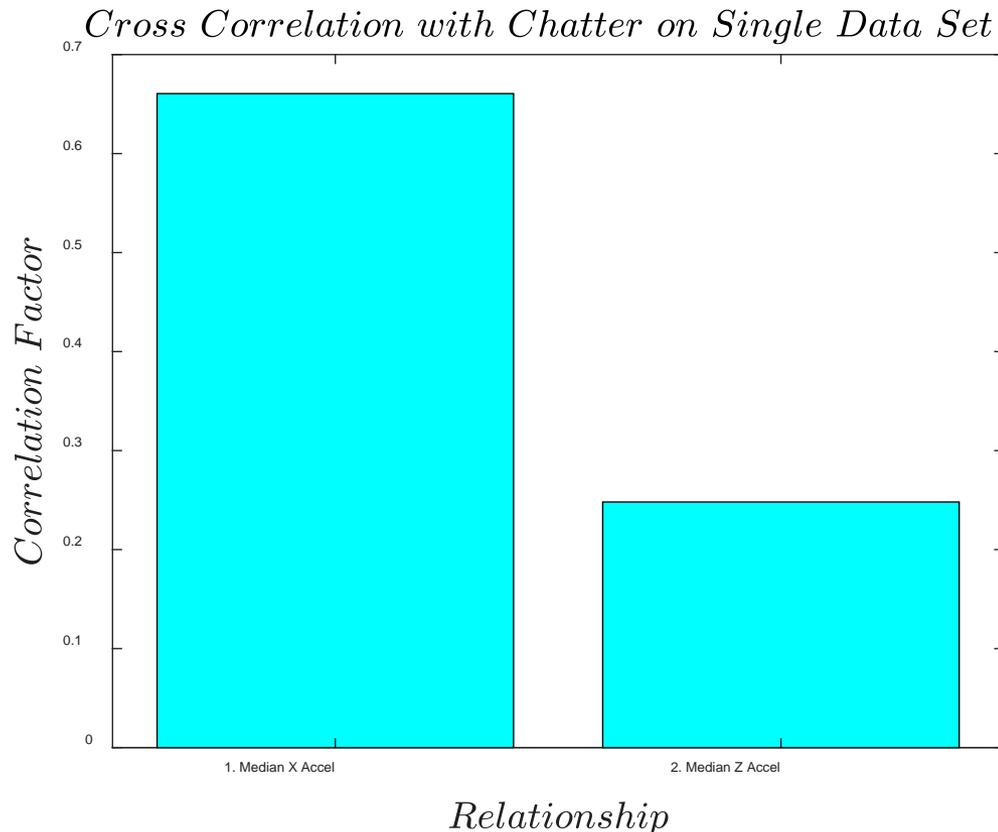


Chatter requires
Off-Axis
Excitation to
occur



The most chatter
occurs with
maximum X and
Z Acceleration

Correlation of Accelerations to Chatter Across Multiple Data Sets



- Cross correlation between chatter and multiple variables was calculated.
- This compares which variables correlate to chatter more.

Analysis Across Single Sets

Introduction

Motivation

Modal

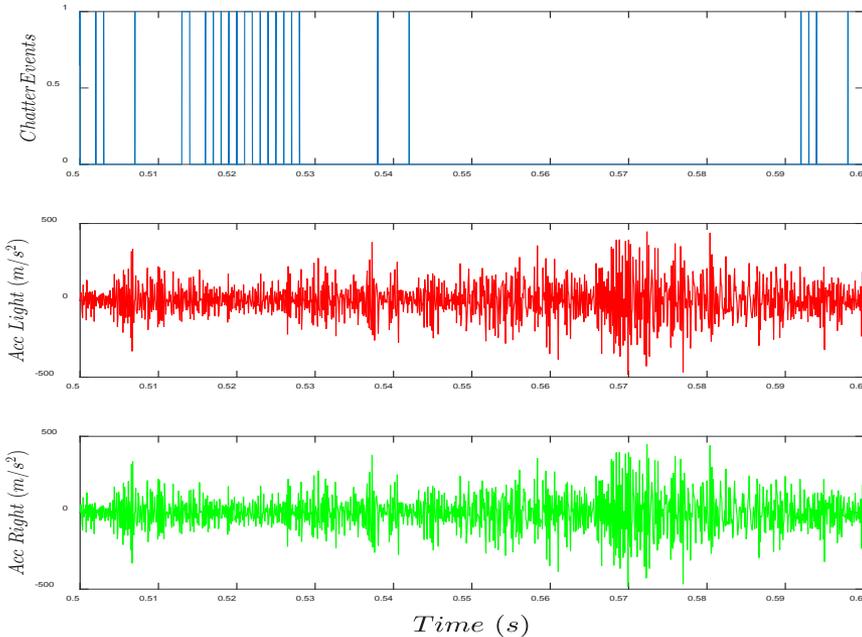
Chatter

Data

Conclusion

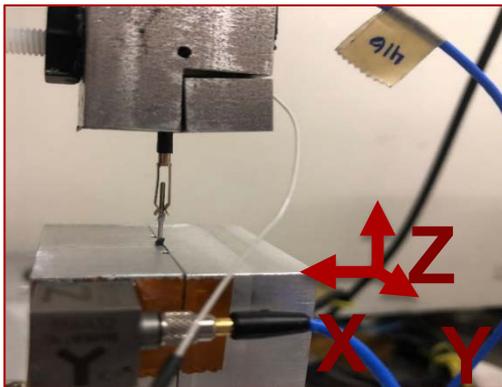
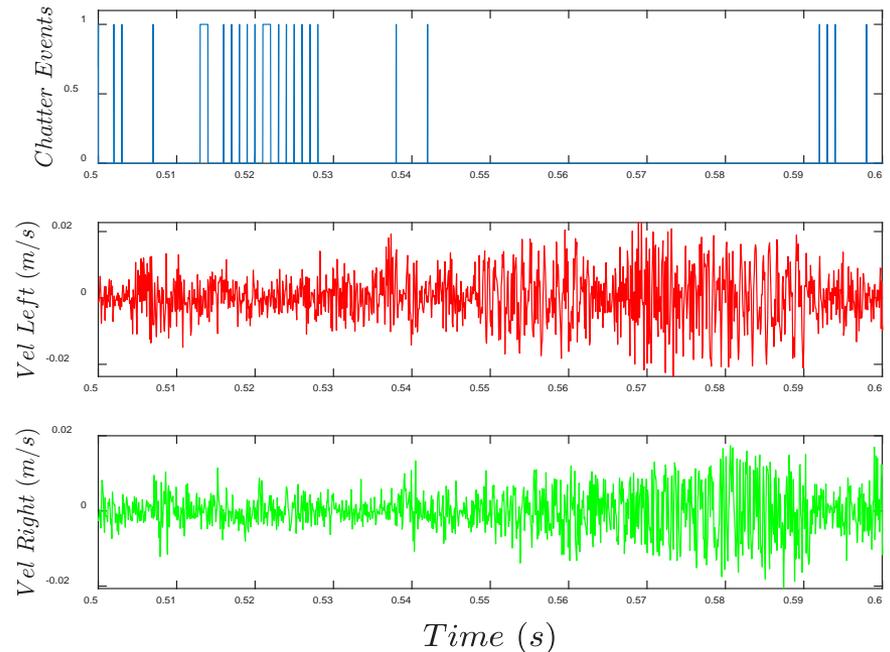
Acceleration and Velocity of Receptacle Legs (Outputs)

Acceleration of Receptacle Legs and Chatter



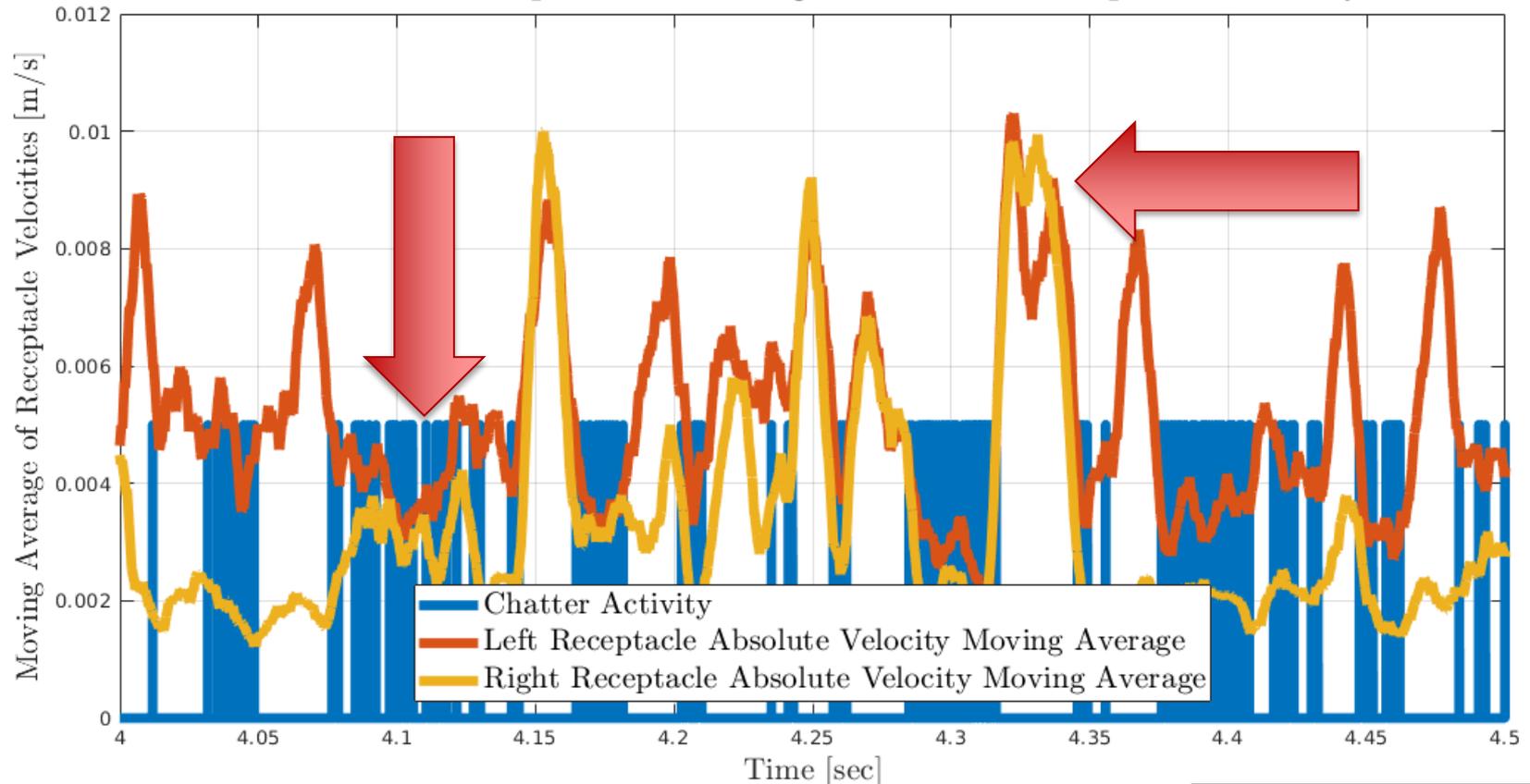
0 = Conductivity
1 = No conductivity

Velocity of Receptacle Legs and Chatter



Receptacle Velocity to Chatter

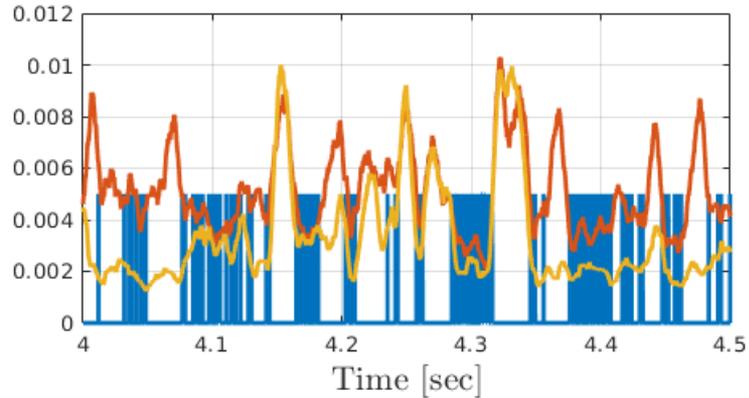
Chatter Occurances Compared to Averaged Absolute Receptacle Velocity vs. Time



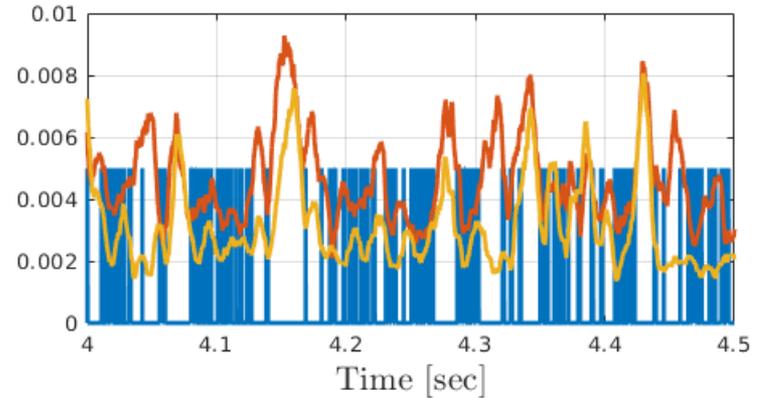
0.0 = Conductivity
0.005 = No conductivity

Receptacle Velocity to Chatter

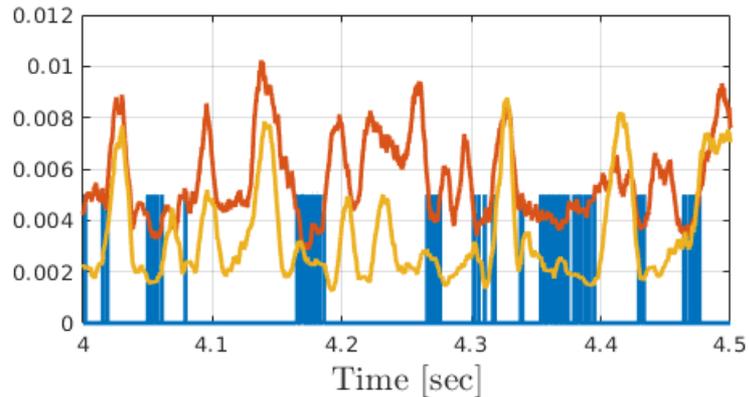
Run 93



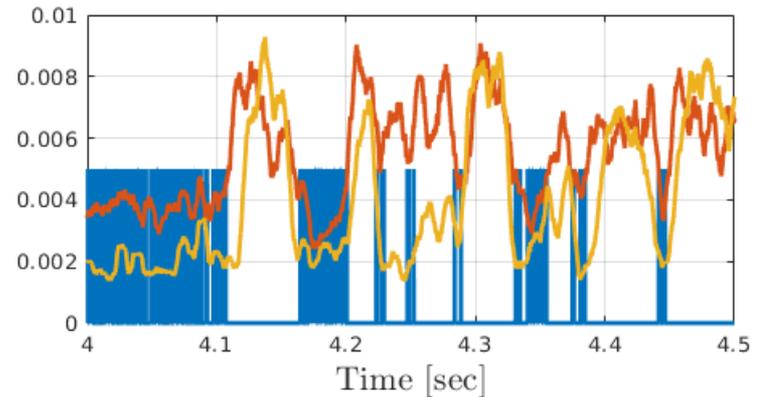
Run 102



Run 147



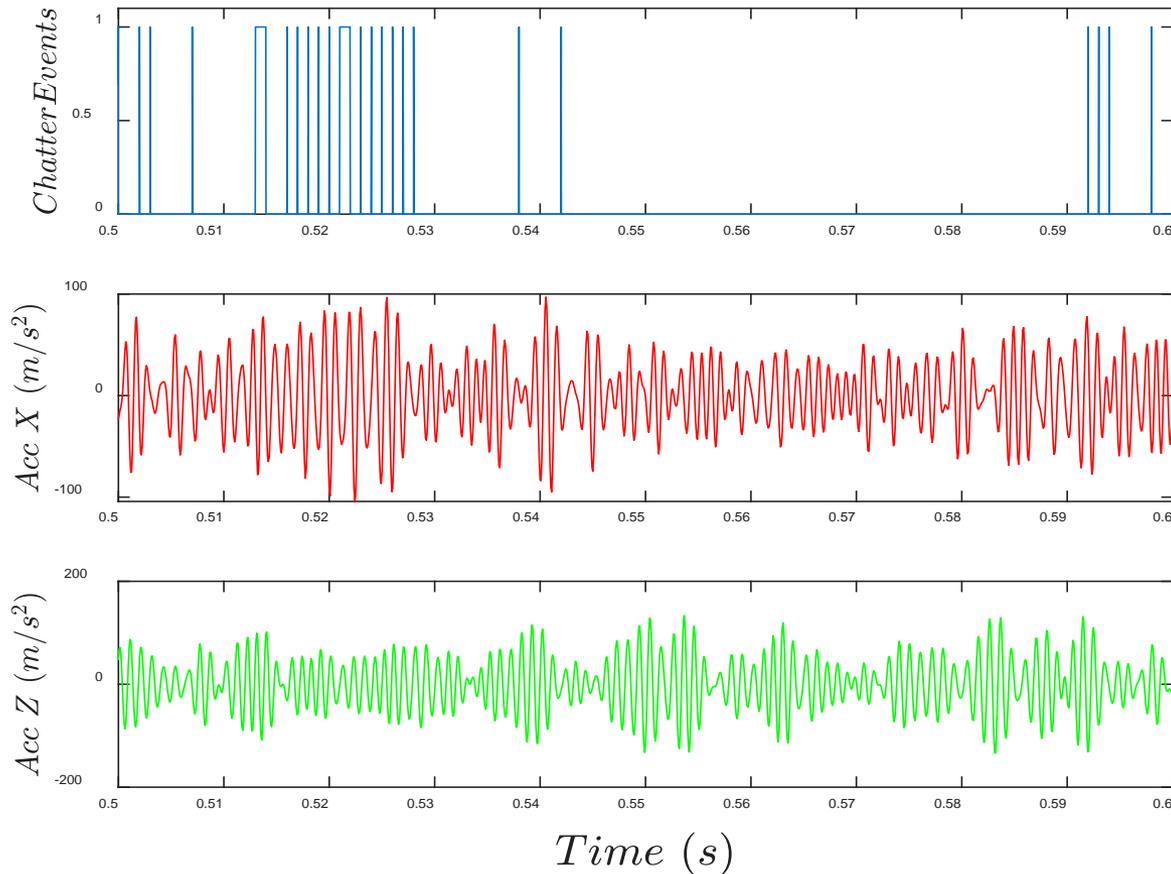
Run 158



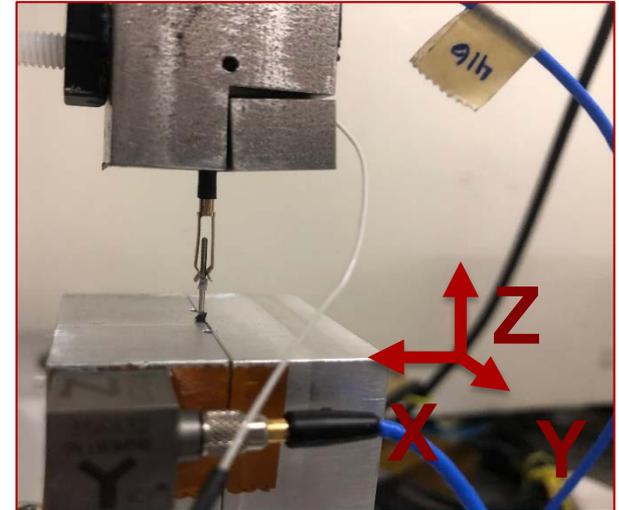
0.0 = Conductivity
0.005 = No conductivity

Input Acceleration and Chatter

Chatter Events and Recep Input Acceleration

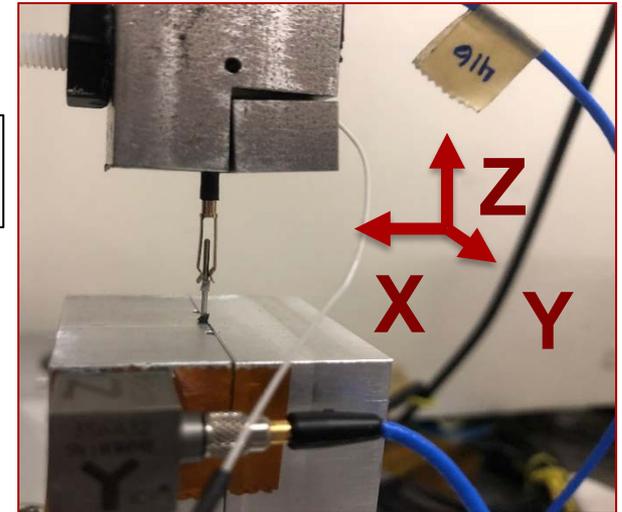
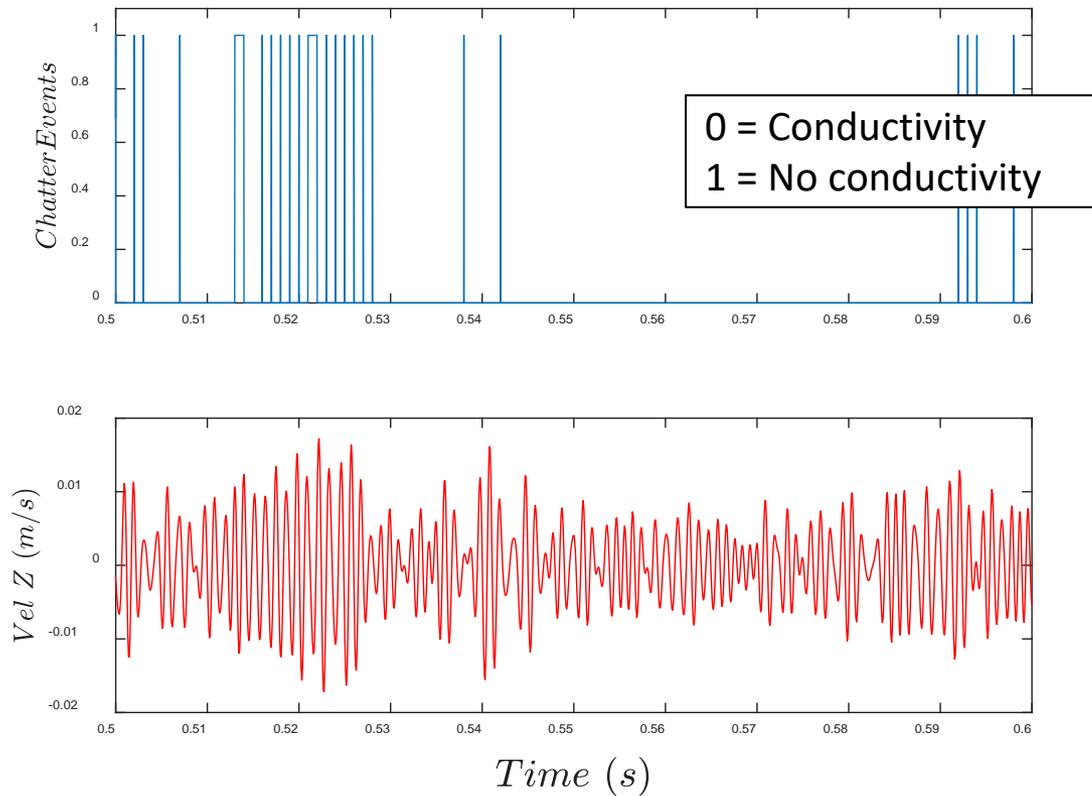


0 = Conductivity
1 = No conductivity



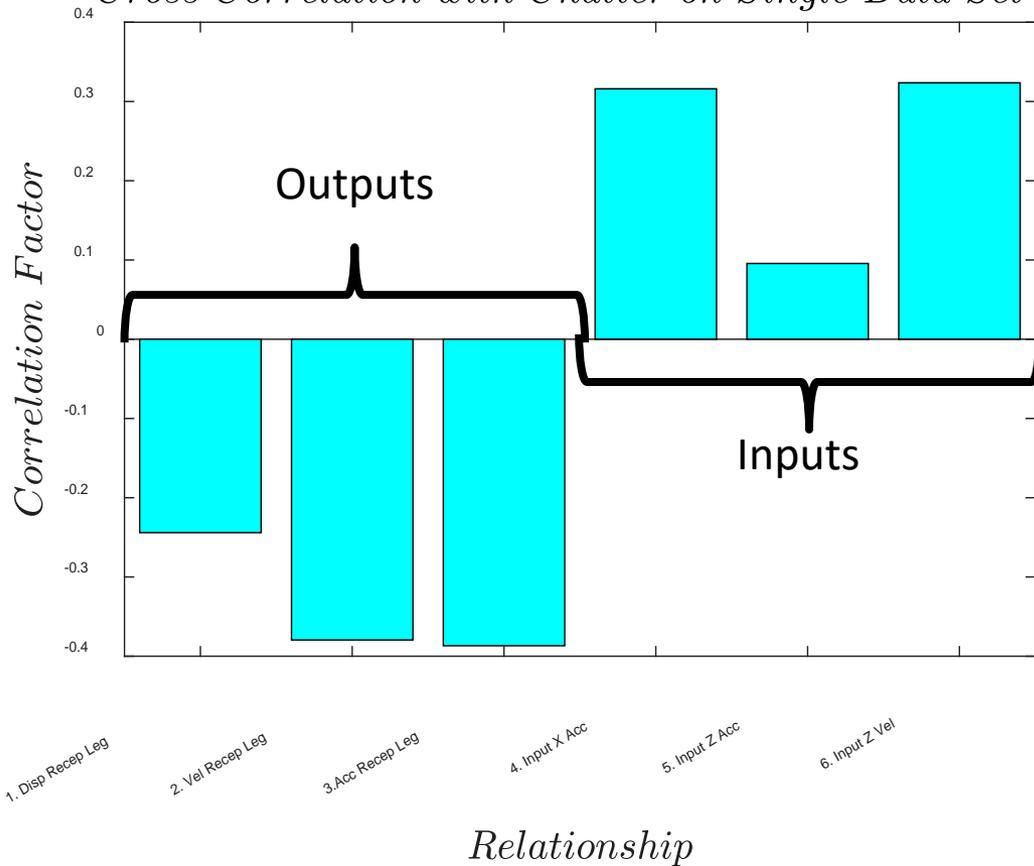
Receptacle Z Input Velocity

Receptacle Z Velocity and Chatter



Correlation Across a Single Set

Cross Correlation with Chatter on Single Data Set



- Cross correlation between chatter and multiple variables was calculated.
- This compares which variables correlate to chatter more.

SM Analysis Results

Introduction

Motivation

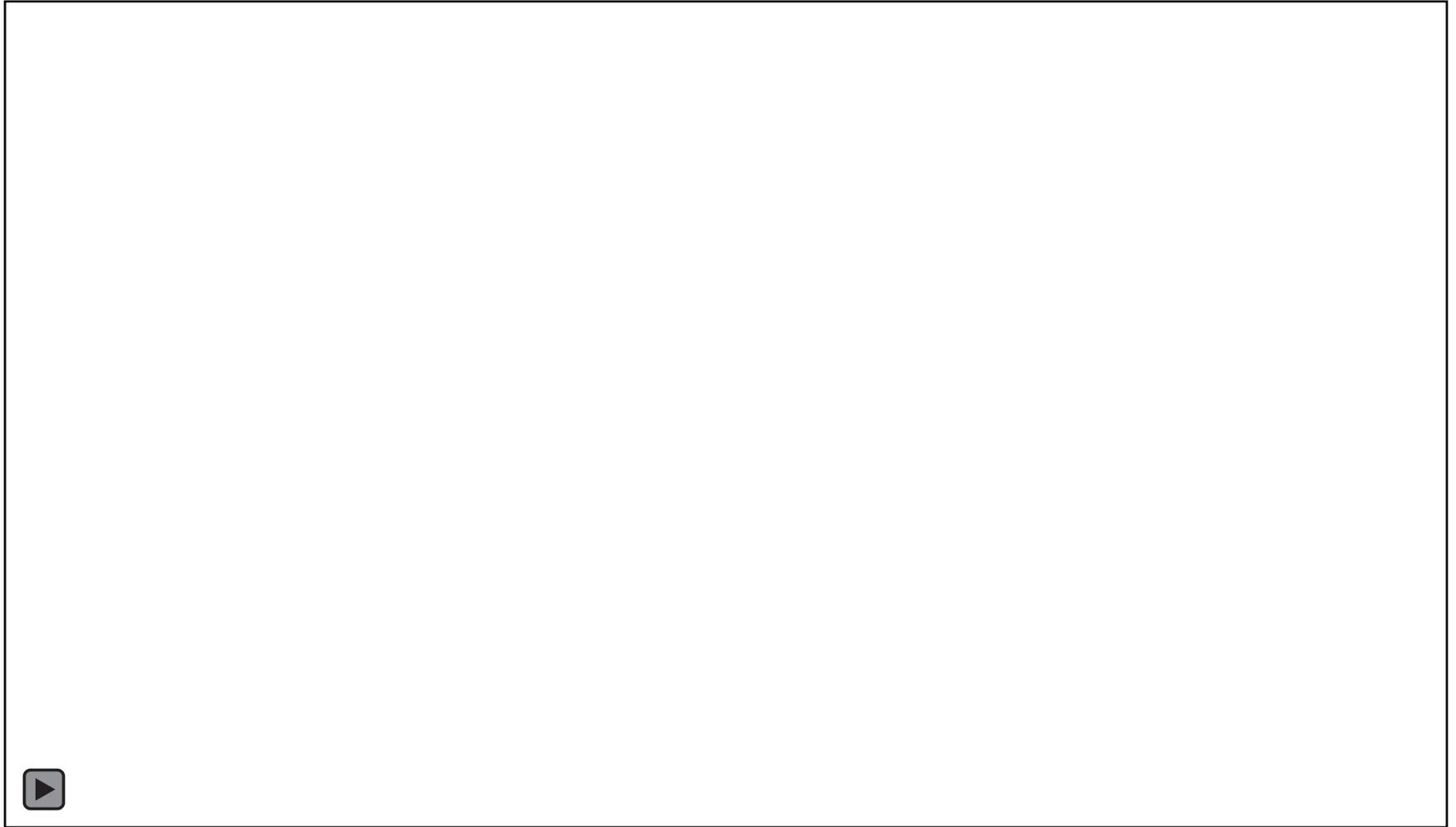
Modal

Chatter

Data

Conclusion

SM Response to Experimental Inputs



Introduction

Motivation

Modal

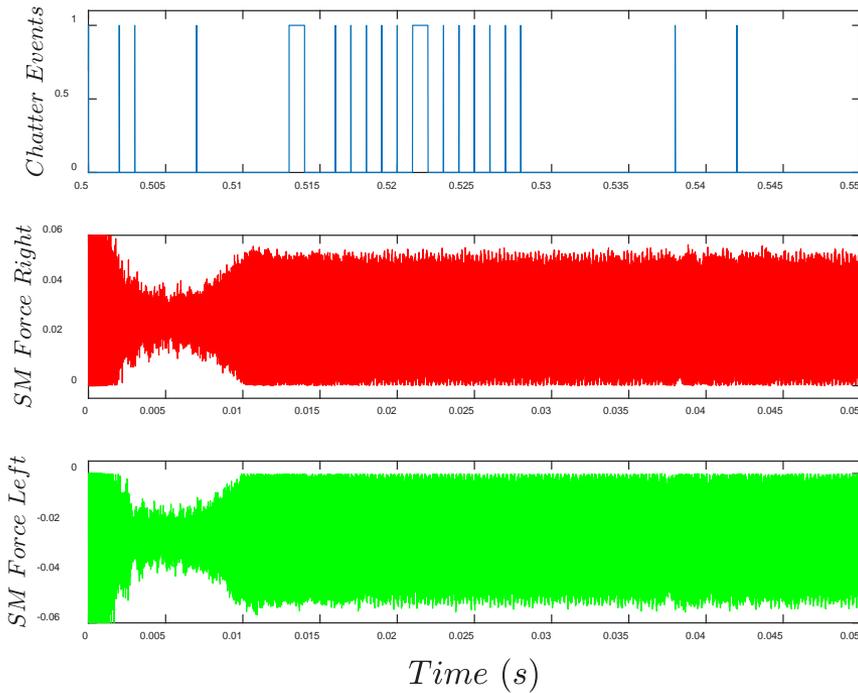
Chatter

Data

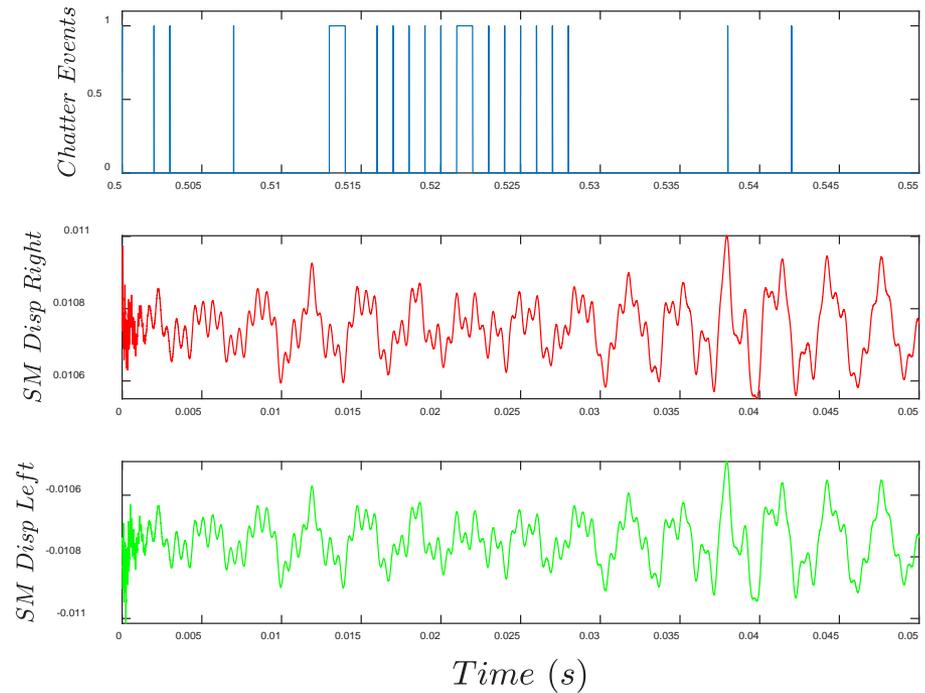
Conclusion

SM Receptacle Displacement to Chatter

Chatter Event And SM Receptacle Force



Chatter Event And SM Receptacle Displacements



0 = Conductivity
1 = No conductivity

Challenges and Limitations

- Lasers
 - Did not use reflective tape in order to keep accurate system dynamics
 - Time delay between laser data and accelerometer
- Chatter Tester
 - LMS channels sample at 204.8 kHz per channel
 - Chatter Tester samples at 40 MHz
- System Mode around 1300 Hz
 - Appeared to be the same area where chatter occurred most
- Same Inputs – Different Results

Closing Remarks

- Ran the first chatter test to obtain acceleration inputs to pin and receptacle
- Created explicit dynamic and linear transient models of pin and receptacle that can use accelerometer data as inputs to simulate test
- Found a high correlation between off-axis motion and chatter occurrence over multiple runs
- Continued work is being done to process data and correlate FEM model to test data

Acknowledgements

- This research was conducted at the 2019 Nonlinear Mechanics and Dynamics Research Institute supported by Sandia National Laboratories and hosted by the University of New Mexico.
- Sandia National Laboratories is a multimission laboratory managed and operated by National Technology and Engineering Solutions of Sandia, LLC., a wholly owned subsidiary of Honeywell International, Inc., for the U.S. Department of Energy's National Nuclear Security Administration under contract DE-NA-0003525.